



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/814,260
Filing Date March 21, 2001
Inventor Scott E. Moore et al.
Assignee Micron Technology, Inc.
Group Art Unit 3723
Examiner T. Eley
Attorney's Docket No. MI22-1663
Title: "Semiconductor Workpiece Processing Methods, A Method of Preparing Semiconductor Workpiece Process Fluid, and A Method of Delivering Semiconductor Workpiece Process Fluid to a Semiconductor Processor"

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

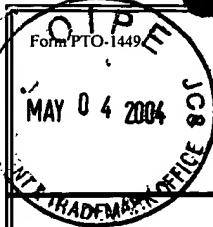
Dated: 5/2/04

Attorney: James D. Shaurette

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		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1663		SERIAL NO. 09/814,260	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Scott E. Moore et al.		FILING DATE March 21, 2001	
				GROUP 3723			

U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	4,152,070	5/1979	Kushner et al.			
	AB	6,100,976	8/2000	Ackerson, Bruce			
	AC	5,828,458	10/1998	Taylor et al.			
	AD	3,653,767	4/19792	Liskowitz et al.			
	AE	3,612,688	10/1971	Liskowitz			
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	AI	5,059,811	10/1991	King et al.			
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	AK	4,263,511	4/1981	Hirschberg, Joseph			
	AL	4,441,960	4/1984	Karnis et al.			
	AM	4,320,978	3/1982	Sato, Ko			
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	AP	5,555,583	9/1996	Berkcan, Ertugrul			
	AQ	5,085,831	2/1992	Hickey et al.			

FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AR						
	AS						
	AT						
	AU						
	AV						

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)	
EXAMINER	DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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